

Korean International Semiconductor Conference & Exhibition on Manufacturing Technology 2025

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Re:Innovation of Semiconductor Manufacturing for AI Ecosystem



X-Ray Research Laboratory, Rigaku Corporation, Japan



Kazuhiko OMOTE: Director, X-Research Laboratory (XRL), Rigaku Corporation.

He joined XRL in 1996 and became director of XRL in 2013. His research fields are X-ray structural analysis, X-ray metrology, and X-ray optics. He developed a lot of instruments and software for X-ray analysis and metrology after joining XRL. He wrote more than hundred scientific papers and has about 60 registered patents. He received Doctor thesis in engineering from the University of Nagoya in 1991.